

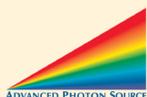
2006 USERS MEETINGS

for DOE/BES User Facilities
 at Argonne National Laboratory

MAY 1–5, 2006

ARGONNE, ILLINOIS

www.aps.anl.gov/Users/Meeting/



ADVANCED PHOTON SOURCE

PLENARY SESSIONS

- CNM – Monday, May 1
- APS – Wednesday, May 3
See Web site for confirmed speakers

DEADLINES

- March 15 Poster Abstracts
- March 31 Registration for Non-U.S. Citizens
- April 14 Housing Reservations
 Registration without Late Fee

PROGRAM CHAIRS

- APS Gene Ice
(Oak Ridge National Laboratory)
- CNM John Rogers
(University of Illinois at Urbana-Champaign)
- EMC Dean Miller
(Argonne National Laboratory)
- IPNS Thomas Koetzle
(Argonne National Laboratory)

AWARDS

- Franklin Young Investigator Award
- Student Poster Prizes

WORKSHOPS

- **Joint Workshops**
 - Microscopy and Imaging in Materials Science
 - Texture and Strain Mapping with X-rays, Neutrons, and Electrons
 - Toward 1-nanometer X-ray Beams
- **Nanoscience**
 - Nanomaterials for Energy
 - Nanopatterning
 - Nanophotonics
 - Quantum Nanomagnetism
- **Synchrotron Science**
 - Beamline Controls
 - Diffuse Scattering
 - Environmental Spectromicroscopy
 - Inelastic X-ray Scattering
 - Microfocus in Structural Biology



INTENSE PULSED NEUTRON SOURCE

CENTER FOR NANOSCALE MATERIALS



ELECTRON MICROSCOPY CENTER